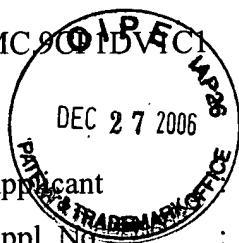


PATENT

ASMMC 901DVC1



INFORMATION DISCLOSURE STATEMENT

Applicant : Sherman
Appl. No. : 10/683,727
Filed : October 10, 2003
For : SEQUENTIAL CHEMICAL
VAPOR DEPOSITION
Examiner : Eric B. Fuller
Group Art Unit : 1762

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

December 22, 2006

(Date)

Andrew N. Merickel, Reg. No. 53,317

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing One (1) reference to be considered by the Examiner. Also enclosed is One (1) foreign patent reference and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

12/28/2006 FMETEKI1 00000012 10683727

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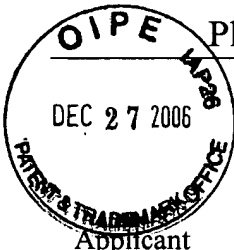
Dated:

December 22, 2006

By:

Andrew N. Merickel
Registration No. 53,317
Attorney of Record
Customer No. 20,995
(415) 954-4114

3240102

Please Direct All Correspondence to Customer Number **20995**

TRANSMITTAL LETTER
INFORMATION DISCLOSURE STATEMENT

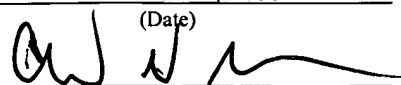
Applicant : Sherman
App. No : 10/683,727
Filed : October 10, 2003
For : SEQUENTIAL CHEMICAL VAPOR
DEPOSITION
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Art Unit : 1762

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(Date)


Andrew N. Merickel, Reg. No. 53,317

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

(X) An Information Disclosure Statement and PTO/SB/08 equivalent listing references for consideration:


(X) Listing 1 reference.

(X) Enclosing 1 reference.

(X) A check in the amount of \$180 to cover the fee for the Information Disclosure Statement is enclosed.

(X) Return prepaid postcard.

Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.


Andrew N. Merickel
Registration No. 53,317
Attorney of Record
Customer No. 20,995
(415) 954-4114

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application No. 10/683,727
 Filing Date October 10, 2003
 First Named Inventor Sherman
 Art Unit 1762
 Examiner Eric B. Fuller
 Attorney Docket No. ASMMC.9CP1DV1C1

(Multiple sheets used when necessary)

SHEET 1 OF 1

U.S. PATENT DOCUMENTS

| Examiner Initials | Cite No. | Document Number Number - Kind Code (if known) Example: 1,234,567 B1 | Publication Date MM-DD-YYYY | Name of Patentee or Applicant | Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear |
|----------------------|-------------|---|--------------------------------|-------------------------------|--|
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FOREIGN PATENT DOCUMENTS

| Examiner Initials | Cite No. | Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1 | Publication Date MM-DD-YYYY | Name of Patentee or Applicant | Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear | T ¹ |
|----------------------|-------------|--|-----------------------------------|----------------------------------|--|----------------|
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NON PATENT LITERATURE DOCUMENTS

| Examiner Initials | Cite No. | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ¹ |
|----------------------|-------------|---|----------------|
| | | MÖLSÄ et al., "Deposition of Cerium Dioxide Thin Films on Silicon Substrates by Atomic Layer Epitaxy," Mat. Res. Soc. Symp., Vol. 325, 1994 Materials Research Society, pp. 341-350 | |
| | | | |

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Examiner Signature

Date Considered

***Examiner:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T¹ - Place a check mark in this area when an English language Translation is attached.